# PTO RECEIPT FOR FILING OF PAPERS

MAR 1 7 2004



# The following papers have been filed:

IDS w/ck#144802 (\$180); PTO-1449 w/7 refs. & 1 abstract; & Search Report

Name of Applicant: Eiji NATORI

Serial No.: 09/819,688

Atty. File No.: 109120

Title (New Cases):

Sender's Initials: JAO:SSK/tbh

PATENT OFFICE DATE STAMP

COPY TO BE STAMPED BY PATENT OFFICE AND RETURNED BY MESSENGER

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Sheet 1 of 1

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Form PTO-144 (REV. 8-83)	Form PTO-1449 US Dept. of Commerce (REV. 8-83) PATENT & TRADEMARK OFFICE			ATTY DOCKET NO. 109120			APPLICATION NO. 09/819,688			
INF	ORMATI	ON DISCLOSURE STATEMENT								
(Use several sheets if necessary)				APPLICANT Eiji NATORI						
•				FILING I March 29			GROUP 2813			
		. U.S.	PAT	ENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER		DATE		NAME	CLASS		SUB CLASS	
		5,624,720	04-	29-1997	Osada et al.					
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		DOCUMENT NUMBER		DATE	(	COUNTRY	··	CLASS	CLASS	
		EP 0 828 012 A1	03-	11-1998	Europe					
		FR 2 729 400 - A1 w/abstract	07-	19-1996	France					
		WO 93/16811	09-	02-1993	WIPO					
		WO 97/33013	09-	12-1997	WIPO		•			
		WO 99/02756	01-	21-1999	WIPO					
		OTHER DOCUMENTS (Inc	cludir	ng Author,	Title, Date, Pertin	ent Pages, etc.)				
	Jpn. J. Appl. Phys. Vol. 33 (1994) pp. 5135-5138 Part 1, No. 9B, Sept. 1994; Effects of O <sub>3</sub> on Growth and Electric Properties of Pb(Zr, Ti)O <sub>3</sub> Thin Films by Photoenhanced Metalorganic Chemical Vapor Deposition.									
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EXAMINER		<u></u>	<u> </u>			DATE	CONSID	ERED		
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Date: August 1, 2003



## **PATENT APPLICATION**

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Eiji NATORI Group Art Unit: 2813

Application No.: 09/819,688 Examiner: D. Hogans

Filed: March 29, 2001 Docket No.: 109120

For: METHOD AND DEVICE FOR MANUFACTURING CERAMICS, SEMICONDUCTOR

DEVICE AND PIEZOELECTRIC DEVICE

### INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection, Notice of Allowance or other action that closes prosecution (e.g., Quayle Action).
  - a. I hereby certify that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. 37 CFR §1.97(e)(1).
- 2. The references were cited in a counterpart Korean Patent Application.
- 3. An English-language Abstract of the non-English language reference is attached hereto for JP 02-200782.

4. WO 92/15112 is a related English language equivalent of KR 10-0202532 B1. These appear to be related to U.S. Patent No. 6,110,531 as all appear related to U.S. Patent Application No. 07/660,428, filed February 25, 1991.

Respectfully submitted,

James A. Oliff

Registration No. 27,075

Seth S. Kim

Registration No. 54,577

JAO:SSK/jfb

Date: March 17, 2004

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE
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INFORMATION DISCLOSURE STATEMENT				109120			09	09/819,688			
(Use several sheets if necessary)				APPLICANT(S) Eiji NATORI							
					FILING DATE March 29, 2001			GROUP 2813			
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		DOCUMENT NUMBER	1	DATE		COUN	TRY	CLASS	SUB CLASS		
	1	JP 02-200782 (w/English Abstract)	08/	09/1960	JAPAN						
	2	WO 92/15112 (English Equivalent of #3)	09/0	03/1992	WIPO						
	3	KR 10-0202532 B1	03/2	20/1999	KOREA						
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		OTHER DOCUMENTS (Inc	cludir	ag Author.	Title Date, Pe	rtinent Pa	iges etc.)				
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Date: March 17, 2004